



Mohanlal Sukhadia University, Udaipur
Thin Film Photovoltaic Laboratory, Department of Physics

EXPERIMENTAL FACILITIES

Equipment pictorial view at the site	Equipment name, make and model (Agency-project)	Applications
	Vacuum Coating Unit (Thermal Evaporator, resistive heating) Hind High Vacuum SMART COAT 3.0 (SERB-EMR)	Coating of different layers to solar cells, Vacuum sealing of ampoules, annealing of thin film samples under vacuum and different environments upto 250°C. Coating of metal contacts to almost all type of solar cells like perovskite, organic, dye sensitized, CdTe, CIGS etc.
	UV Vis. Spectrophotometer SHIMADZU UV1780 (SERB-EMR)	To undertake optical properties of thin film and liquid samples like optical energy band gap, refractive index, extinction coefficient and absorption coefficient etc.
	Spin Coating System APEX spinNXGP1 (SERB-EMR)	Coating of different transport layers to solar cells through solution process spin coating route under different environments.
	Source Meter AGILENT B2901A (UGC-MRP)	To undertake electrical properties of thin films and devices.
	Muffle Furnace SONAR (DEPARTMENT)	Annealing of thin film and powder samples in air atmosphere upto 1100°C.
	Ultra Sonication Bath LABMAN (RUSA-MHRD)	To undertake cleaning of the substrates for thin film and device development.
	Magnetic Stirrer LABMAN and Quantum Dot Development System (RUSA-MHRD)	To prepare different samples and to develop Quantum Dots for solar cell devices.
	Hydrothermal Autoclave TECHINSTRO (SERB-EMR)	To synthesize metal organic frameworks (MOFs) for storage devices and solar cell devices.

Equipment pictorial view at the site/ expected	Equipment name, make and model (Agency-project)	Applications
	<p>Solar Simulator (Comprising of Xenon source, probe station, source meter etc) ScienceTech (RUSA 2.0 R&I)</p>	<p>To undertake current-voltage measurements followed by software driven performance parameters like short circuit current, open circuit voltage, fill factor, power conversion efficiency for substrate and superstrate architected solar cell devices.</p>
	<p>Vacuum Annealing System Mansha Vacuum Equipments MVEVAS-2011 (RUSA 2.0 R&I)</p>	<p>To anneal thin film single layers and devices under vacuum conditions within temperature range upto 550 °C and vacuum level upto 10⁻³ mbar in order to prevent activation or treatment from the environmental constituents.</p>
	<p>Hot Air Oven Tempstar KL-103 (SERB-EMR)</p>	<p>To prepare and heat treat the samples in air ambient upto 250 °C temperature. Specially, it is applied to prepare metal organic frameworks (MOFs) and quantum dots to implicate these in solar cell and other optoelectronic devices.</p>
	<p>Centrifuge Machine Laby T-8M (SERB-EMR)</p>	<p>To prepare metal organic frameworks (MOFs) and other materials where the equipment is employed for centrifuging.</p>
	<p>Fume Hood To be purchased under RUSA 2.0 Research and Innovation Project</p>	<p>To clean the substrates for developing devices and the equipment is a basic facility in the wet Chemistry processes.</p>
	<p>RF Sputtering System To be purchased under FIST Physical Sciences Level C-Project</p>	<p>To deposit various single layers to the solar cell devices as per desired architecture where the system bears merits over the others as detailed in international panorama.</p>
	<p>Electron Beam Evaporation System To be purchased under FIST Physical Sciences Level C-Project</p>	<p>To deposit various single layers to the solar cell devices as per desired architecture where the system bears merits over the others as detailed in international panorama.</p>

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